511.33114VV4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

HAGIWARA, et al.

Serial No.:

09/482,859

Filed:

January 14, 2000

For:

PATTERN FORMING PROCESS USING PHOTOSENSITATIVE

AUG 3 1 2000

RESIN COMPOUND

Group:

1752

Examiner:

J. Chu

RESPONSE

Assistant Commissioner for Patents Washington, D.C. 20231

August 31, 2000

sir:

In response to the Office Action mailed June 1, 2000, setting a three-month shortened statutory period for response, Applicants respectfully elect the Group I claims (claims 1-9, drawn to a semiconductor device). This election is made without traverse.

In view of the foregoing, consideration of the Group I claims, on the merits, in due course, is respectfully requested.

To the extent necessary, Applicants petition for an extension of time under 37 CFR § 1.136. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Deposit

09/18/2000 RUIHBUSH 00000001 012135 09482859

01 FC:116

380.00 CH

Account No. 01-2135 (Case No. 511.33114VV4) and please credit any excess fees to such Deposit Account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

William I. Solomon

Registration No. 28,565

1300 North Seventeenth Street

Suite 1800

Arlington, VA 22209

Tel.: 703-312-6600

Fax.: 703-312-6666

WIS/slk